

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of Applicants:

Date: December 16, 2009

Haight et al.

Group Art Unit: 3742

Serial No.: 09/933,461

Examiner: Geoffrey S. Evans

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For: METHOD FOR MINIMIZING SAMPLE DAMAGE DURING THE ABLATION OF
MATERIAL USING A FOCUSED ULTRASHORT PULSED LASER BEAM

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Amendments to the Specification begin on 2 page of this paper.

Remarks begin on 3 page of this paper.